

00862.022183



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Haruhito ONO et al.) : Examiner: I. Soward
Application No.: 09/819,737) : Group Art Unit: 2822
Filed: March 29, 2001) : Confirmation No.: 4343
For: ELECTROOPTIC SYSTEM ARRAY,)
CHARGED-PARTICLE BEAM : May 6, 2004
EXPOSURE APPARATUS USING THE)
SAME, AND DEVICE :
MANUFACTURING METHOD)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: